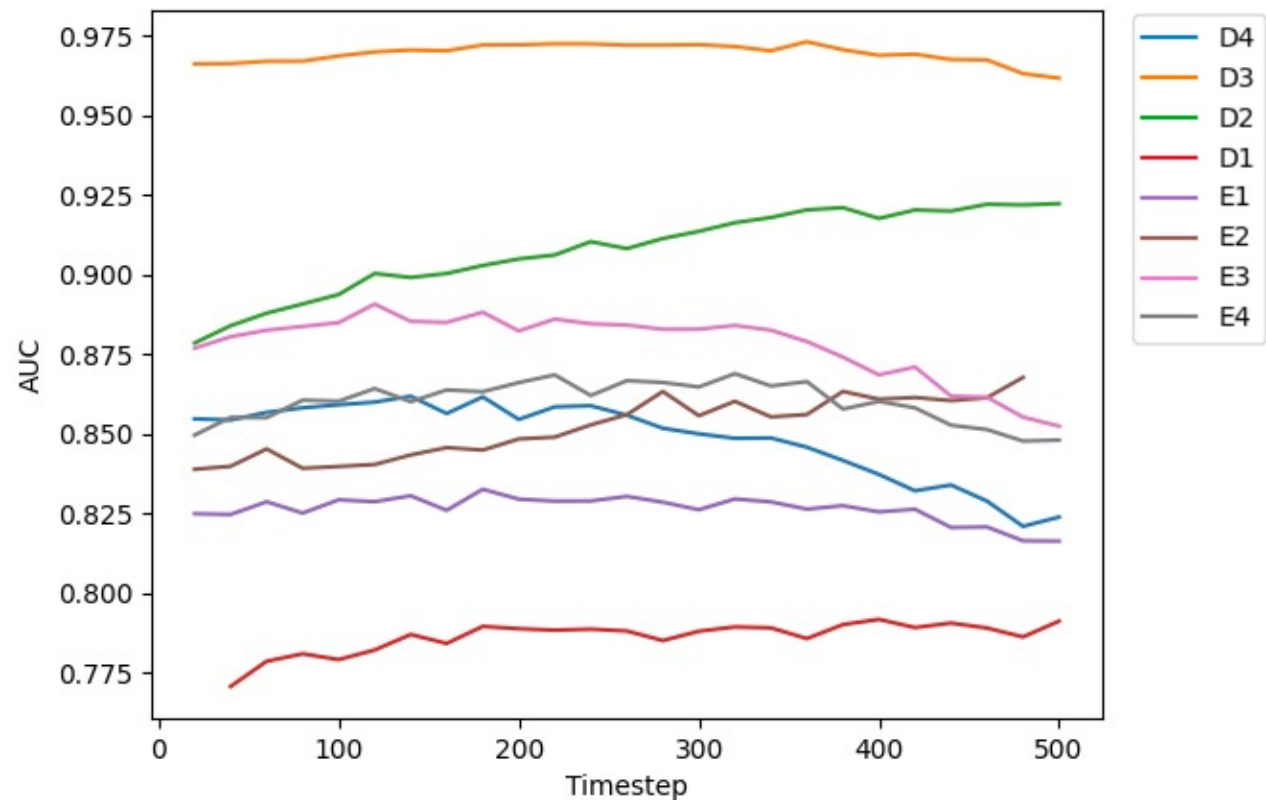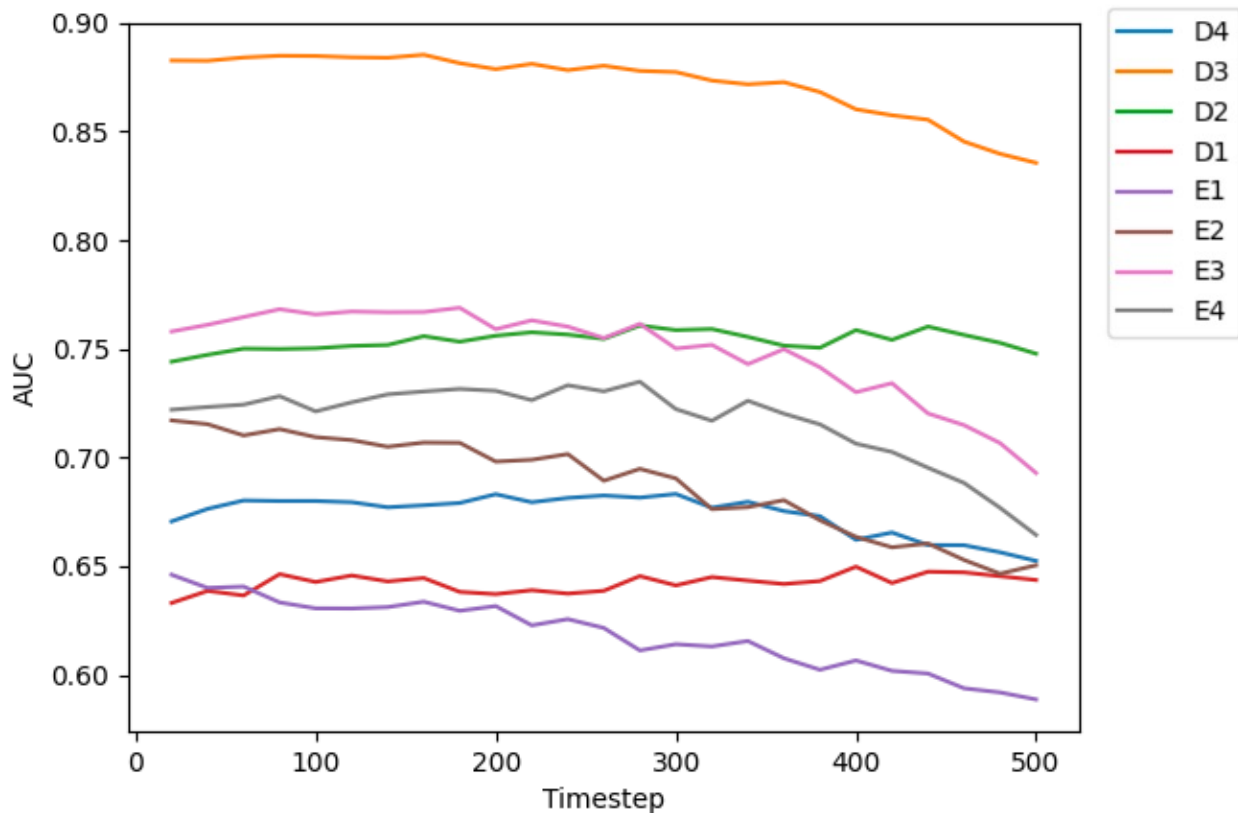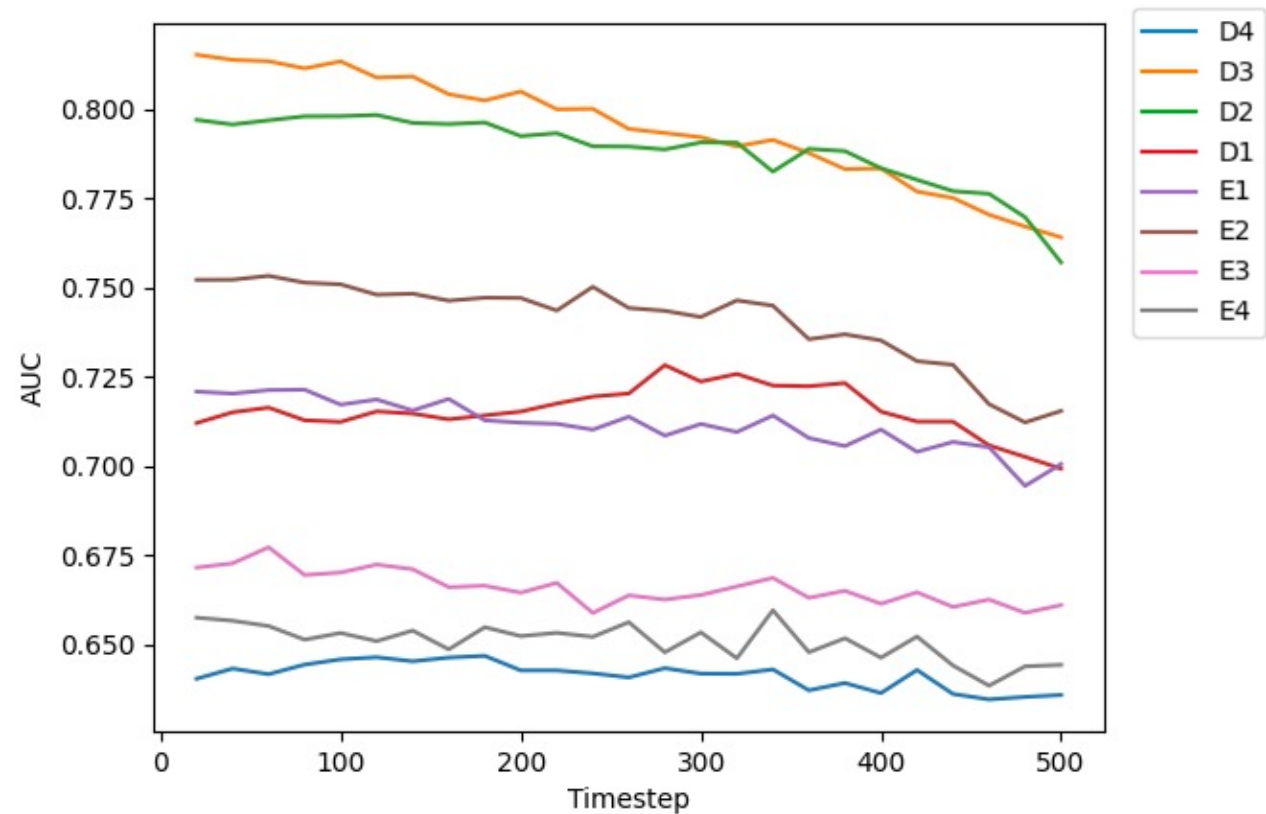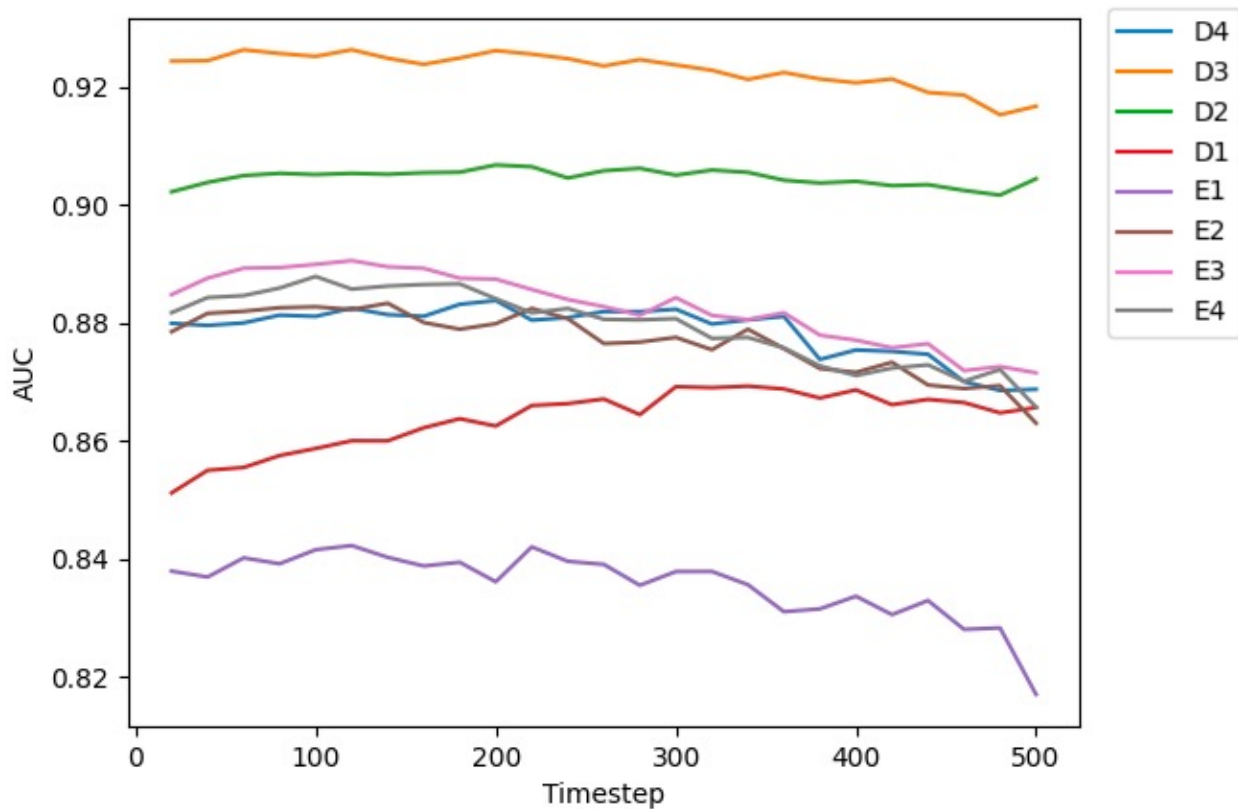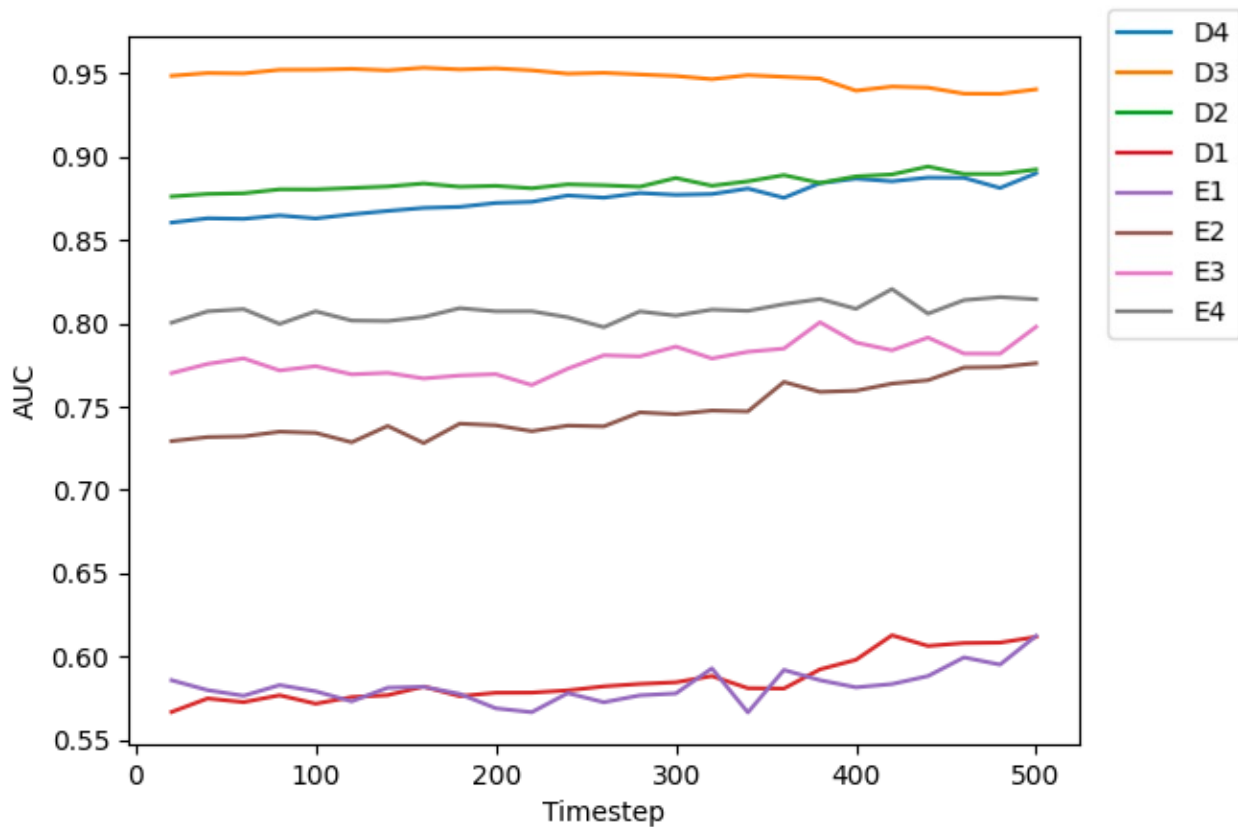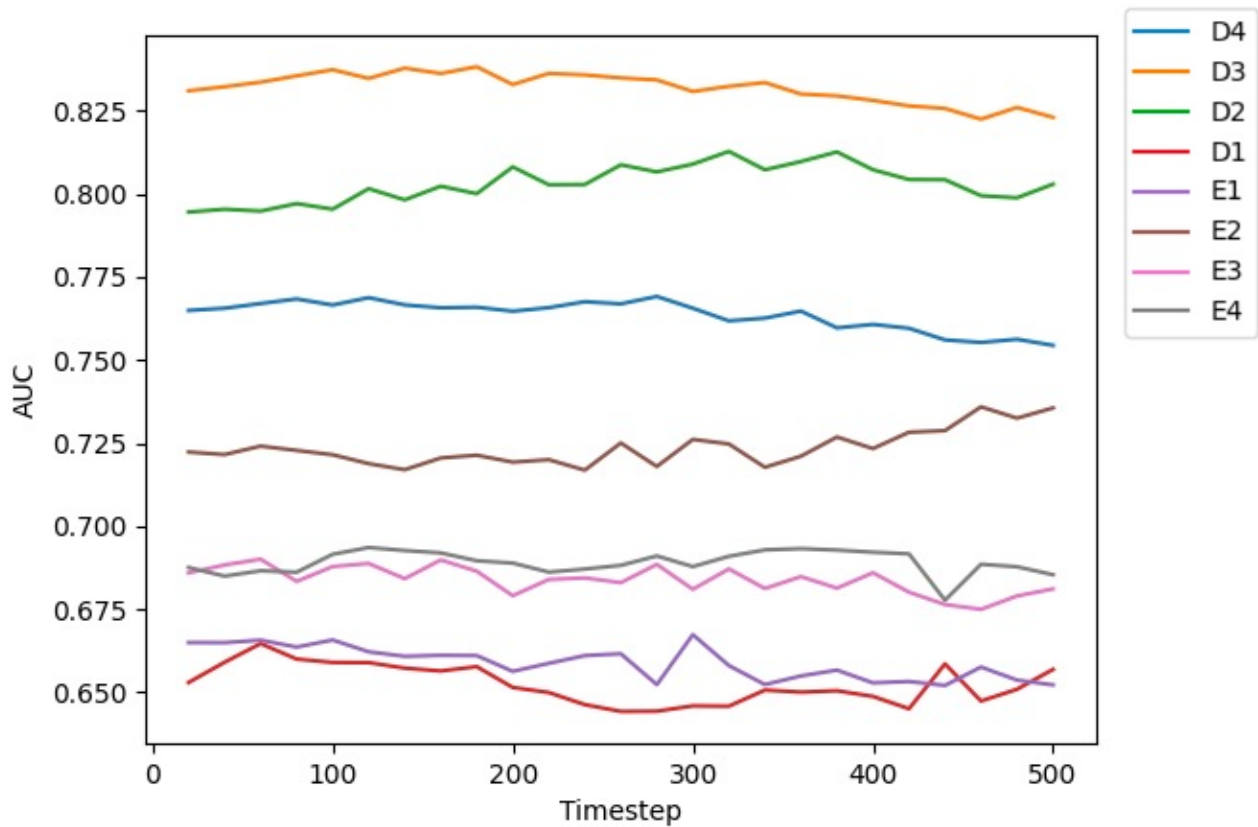Same Plane

Perpendicular Plane

Material

Support Relation

Shadow

Occlusion

Depth